

Appl. No. 10/762,676
Amdt. Dated June 5, 2006
Reply to Office Action of February 7, 2006

Attorney Docket No. 81872.0055
Customer No.: 26021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUN 05 2006

In re application of:

Yosuke INOMATA

Serial No: 10/762,676

Confirmation No.: 5144

Filed: January 22, 2004

For: MULTICRYSTALLINE SILICON
SUBSTRATE AND PROCESS FOR
ROUGHENING SURFACE THEREOF

Art Unit: 1765

Examiner: Eric Brice Chen

I hereby certify that this correspondence
is being transmitted via facsimile to
(571) 273-8300;
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450 on

June 5, 2006

Date of Deposit

Diane Lynn

Name

Signature

06/05/06

Date

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a one-month extension of time extending to June 7, 2006, the period for response to the Office Action dated February 7, 2006. Please charge the fee of \$120 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

Lawrence J. McClure
Lawrence J. McClure
Registration No. 44,228
Attorney for Applicant(s)

Date: June 5, 2006

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